

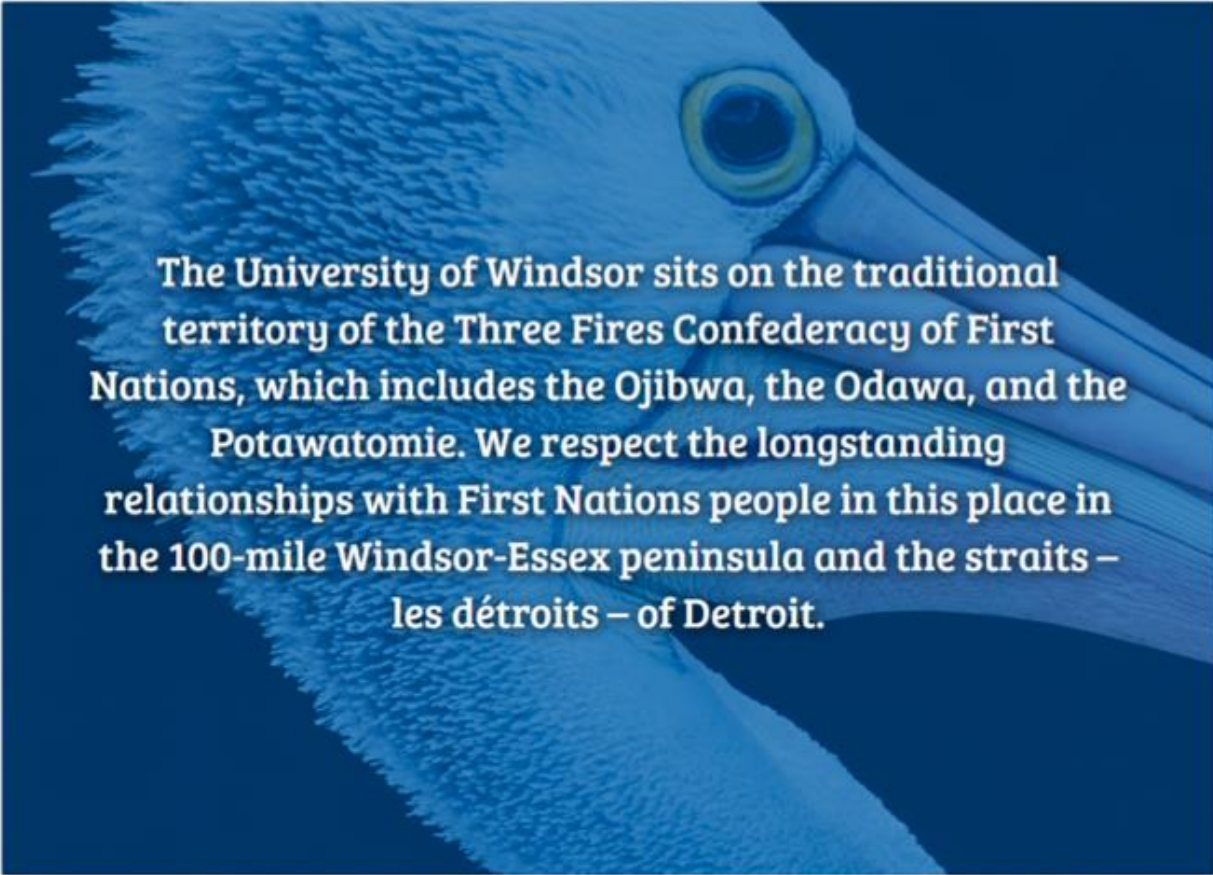
# Pulsed Laser Deposition of a Silver Film For Laser-Induced Breakdown Spectroscopy Emission Enhancement of Bacteria

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**The University of Windsor sits on the traditional territory of the Three Fires Confederacy of First Nations, which includes the Ojibwa, the Odawa, and the Potawatomie. We respect the longstanding relationships with First Nations people in this place in the 100-mile Windsor-Essex peninsula and the straits – les détroits – of Detroit.**



# Motivation

Current methods of bacterial identification in clinical settings are contributing to the ongoing antibiotic resistance crisis:

→ They can be slow (take 2-3 days)

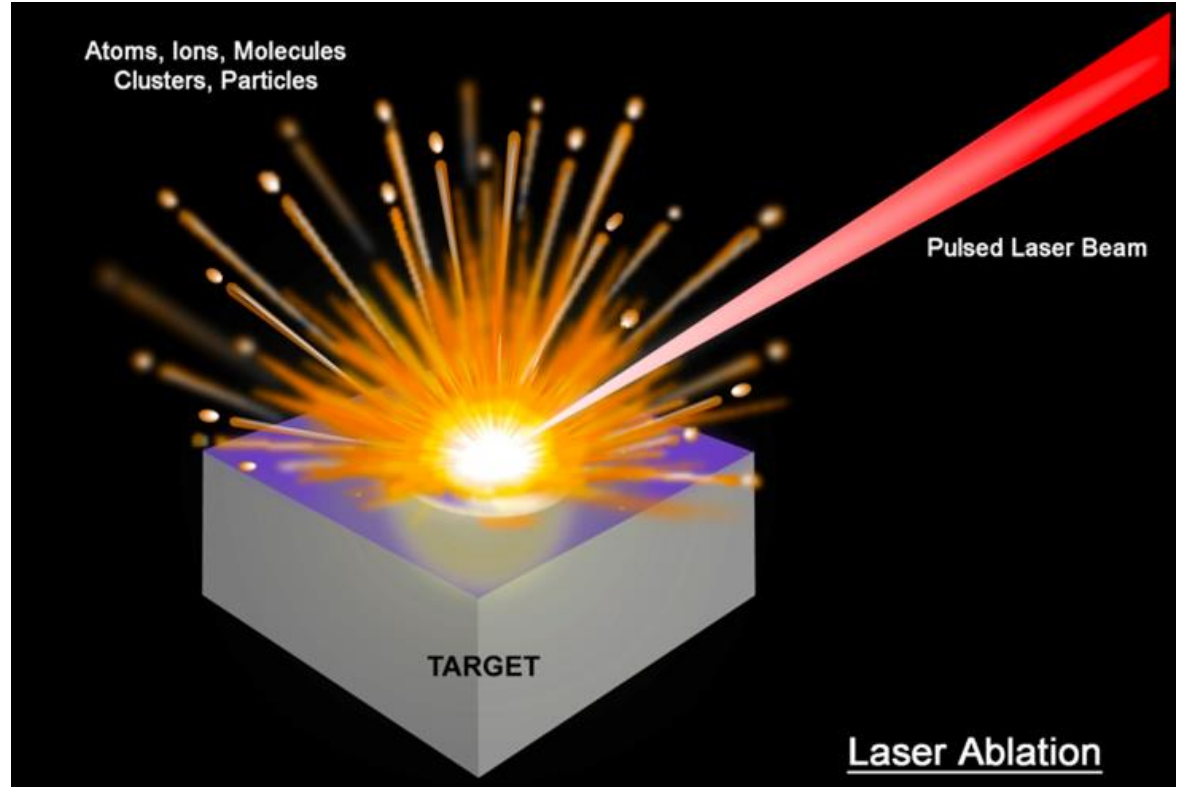
We use laser-induced breakdown spectroscopy (LIBS) on bacteria to identify and classify the bacteria species

→ It's very fast (under 1 min) and requires minimal sample preparation



# What is LIBS?

A spectrochemical technique used to rapidly determine elemental composition



# LIBS Experimental Setup

Argon purge chamber

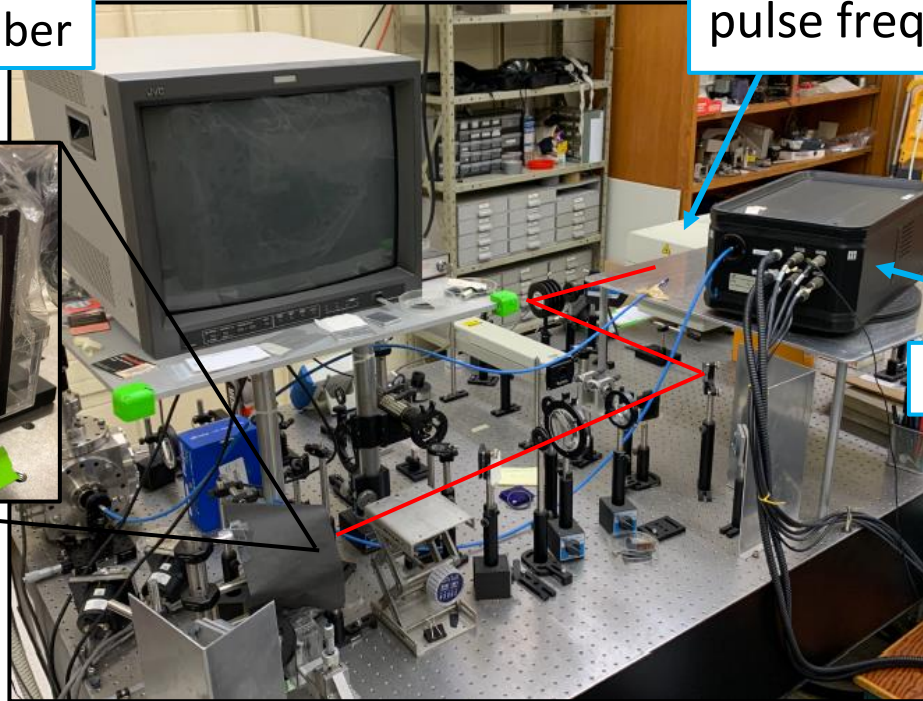
Bacteria sample  
being ablated



Bacteria deposited on  
nitrocellulose filter

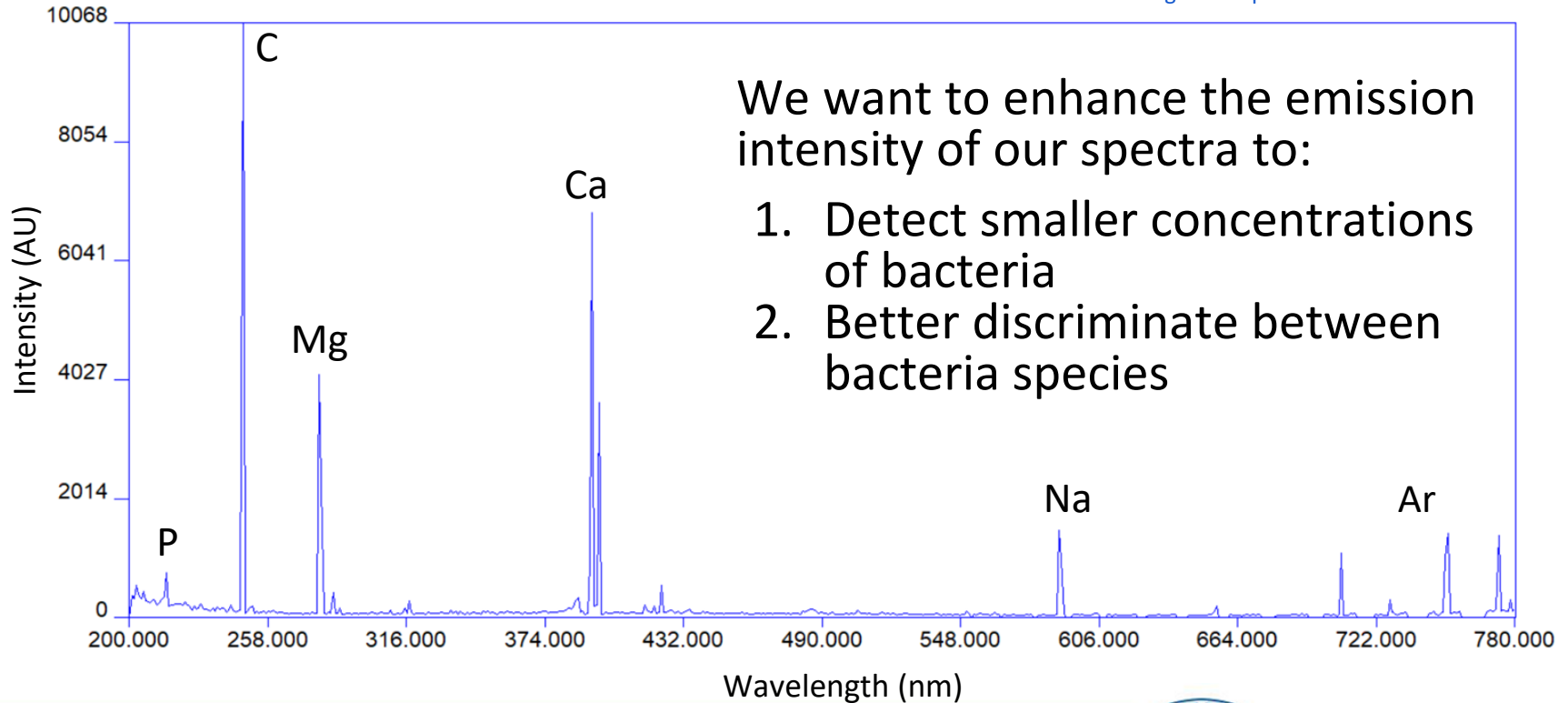
Nd:YAG 1064 nm laser, 10  
ns pulse duration, 10 Hz  
pulse frequency

Echelle spectrometer



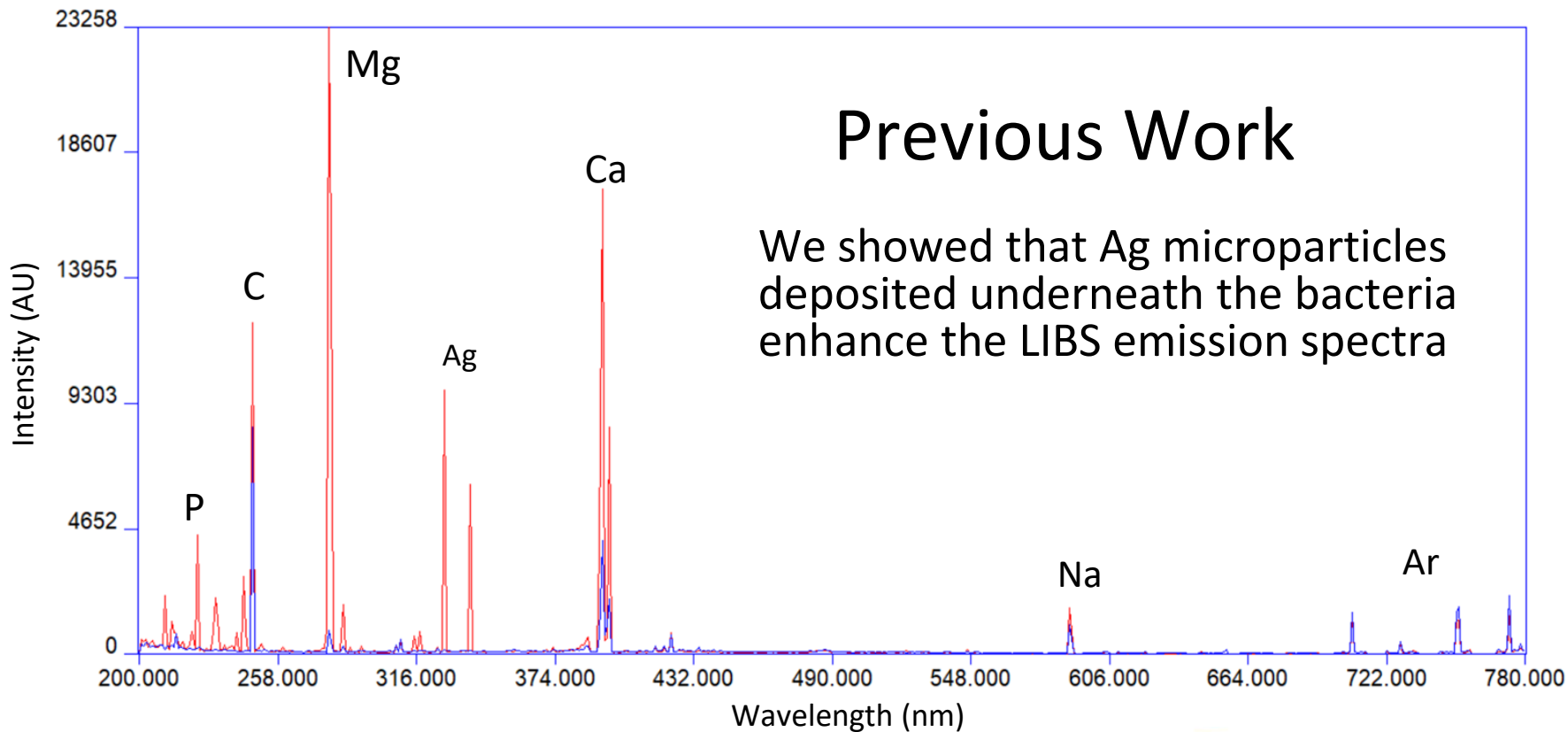
# Typical LIBS Bacteria Spectrum

*E. coli*  
2  $\mu$ s delay after plasma initiation  
20 SCFH Argon environment  
Single laser pulse



Red: with silver microparticles

Blue: without silver microparticles



## Previous Work

We showed that Ag microparticles deposited underneath the bacteria enhance the LIBS emission spectra



# Complications:

The silver microparticles are being displaced by the plasma shockwave.

## Why is this a problem?

During data collection, several pulses must be taken on the filter.

The intensity of silver decreases after each subsequent pulse and therefore the enhancement due to the silver decreases as well.

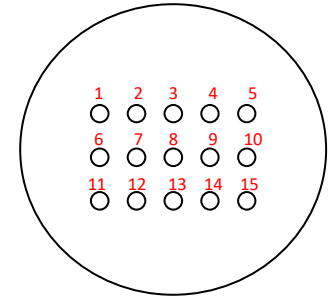
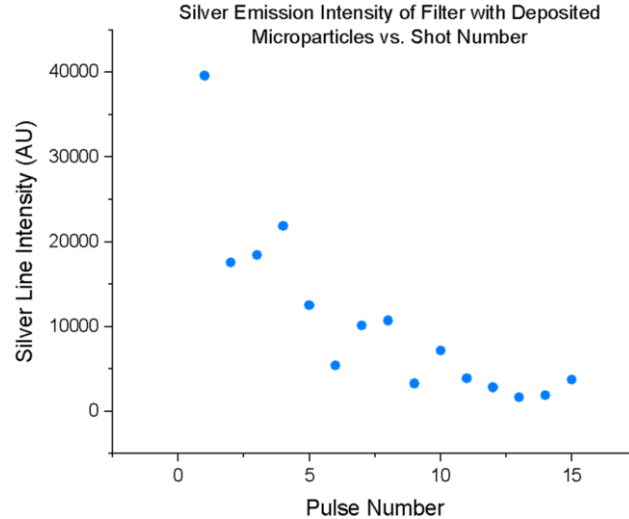
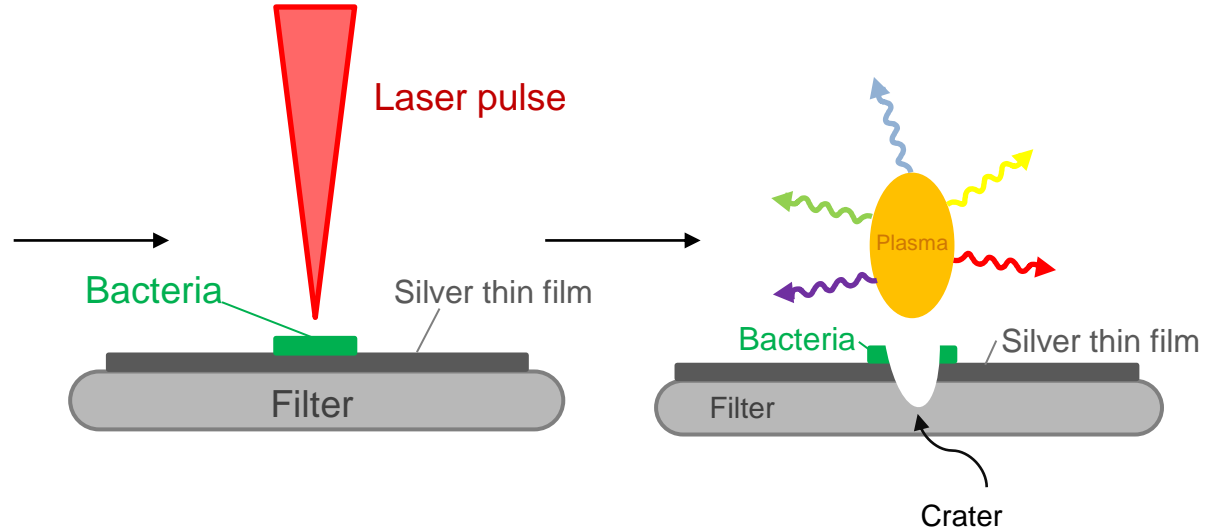
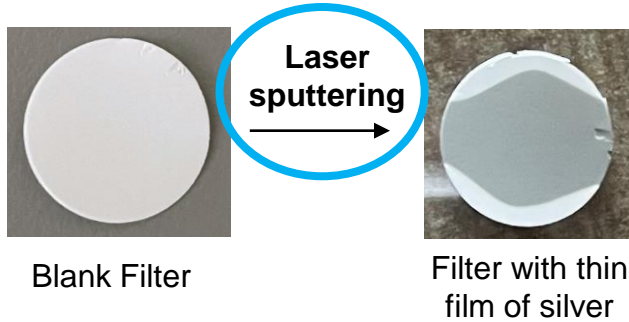


Illustration of 15 pulses on a filter

**Proposed solution: Laser sputtering of a thin film**



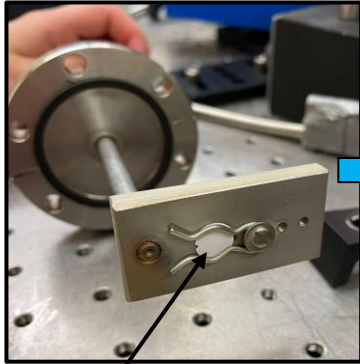
# Method:



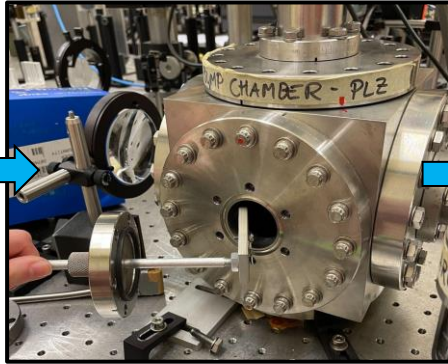
# Pulsed Laser Sputtering

A 1064 nm pulsed laser (60 mJ per pulse) is focused onto a rotating silver target inside a vacuum chamber.

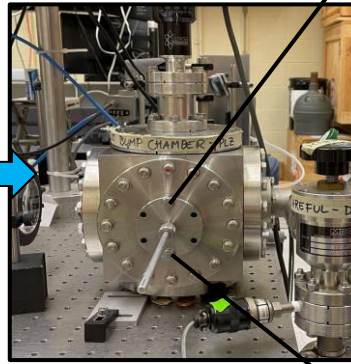
Experimental setup:



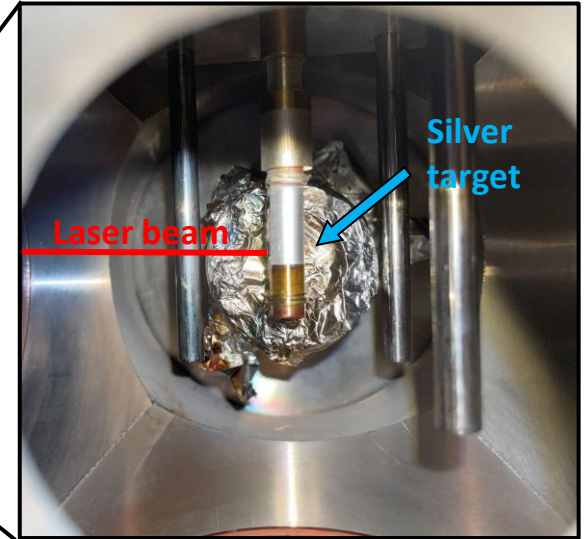
Filter on custom aluminum filter holder



Filter holder being inserted into 10 mTorr evacuated chamber

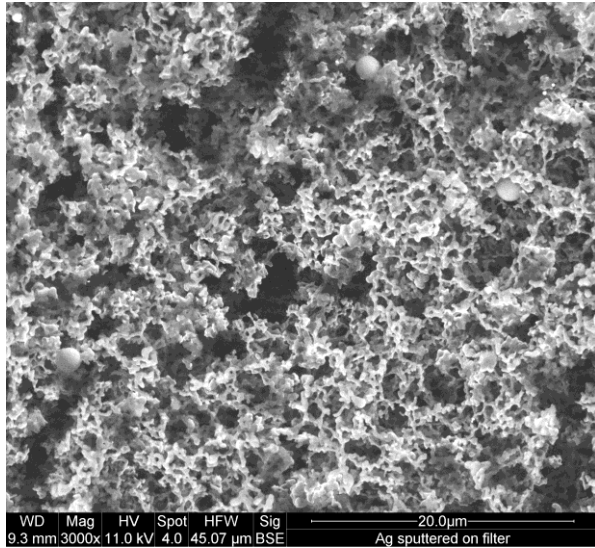


Closed vacuum chamber apparatus

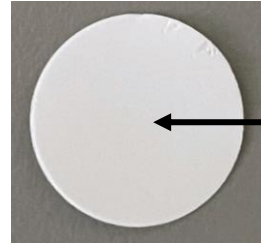
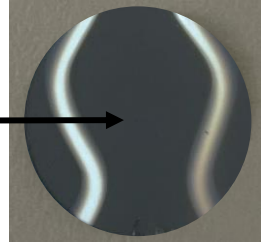


Inside the chamber

# Results: Silver Film Analyzed with Scanning Electron Microscope (SEM)



Filter with 20 min Ag

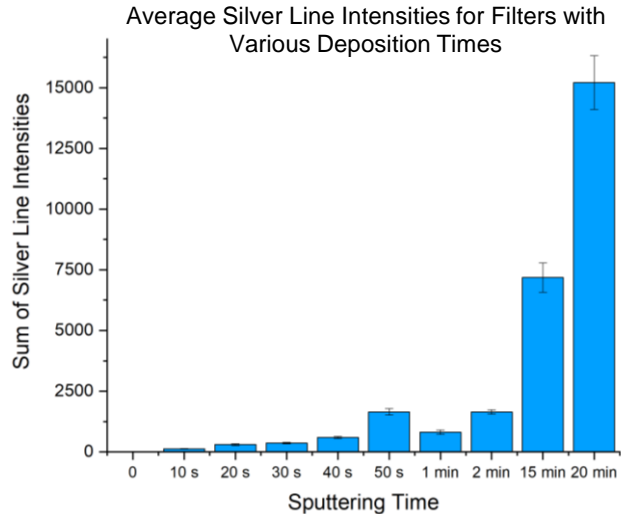


Blank Filter

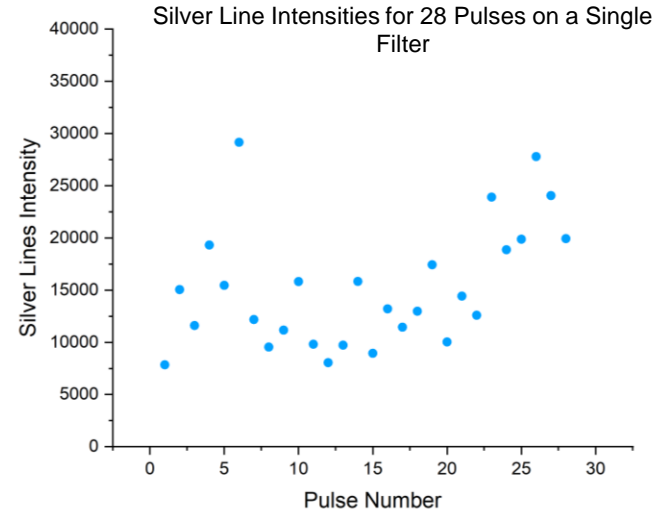
The structure of the filter is unchanged but it is clear that silver has coated the filter.

# Results: Silver Film Analyzed with LIBS

Filters were coated with different amounts of silver by using different sputtering times. The filters were removed from the vacuum chamber and 10 single-shot LIBS spectra were acquired on each filter.



Silver line intensity increases with deposition time.



Silver line intensity shows no decrease with subsequent pulses.

# Method:

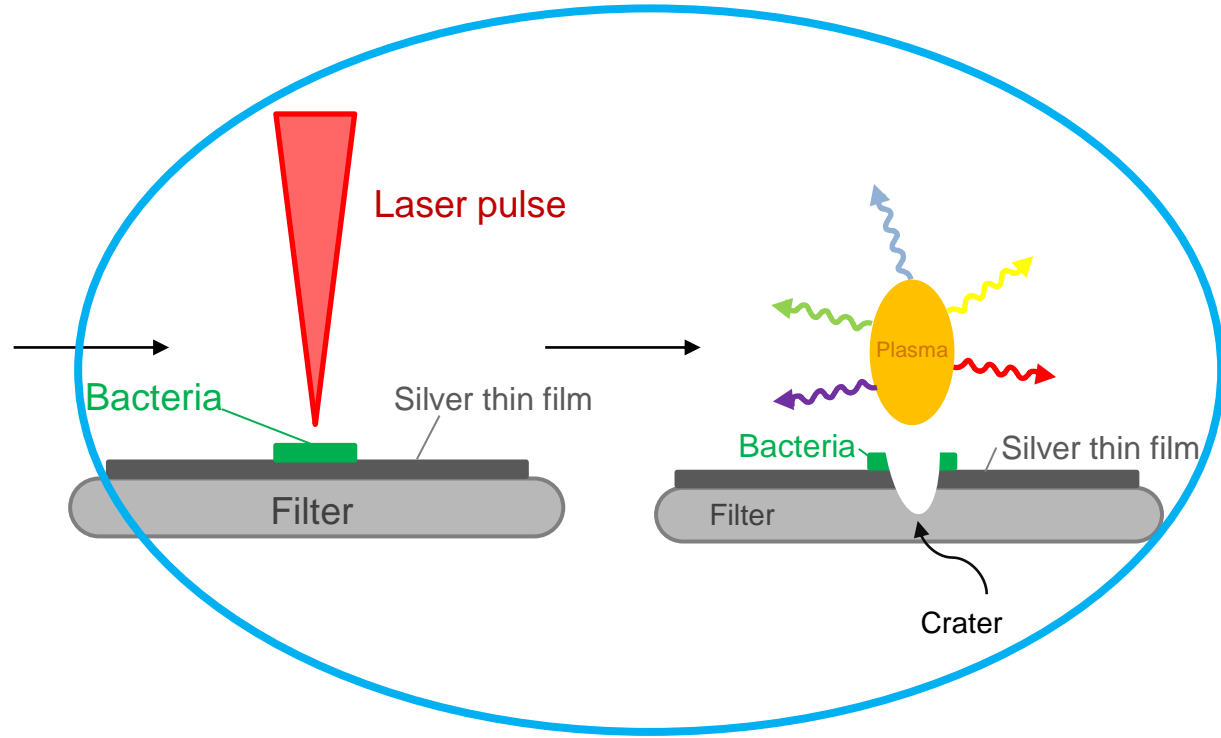


Blank Filter

Laser sputtering

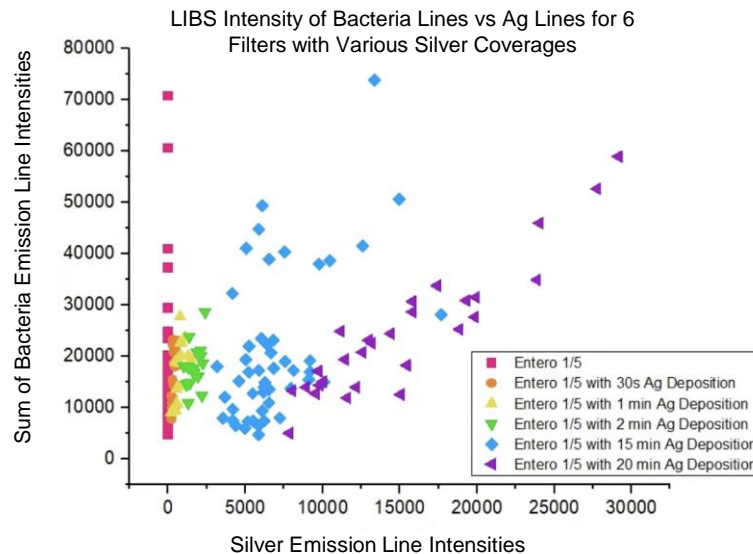
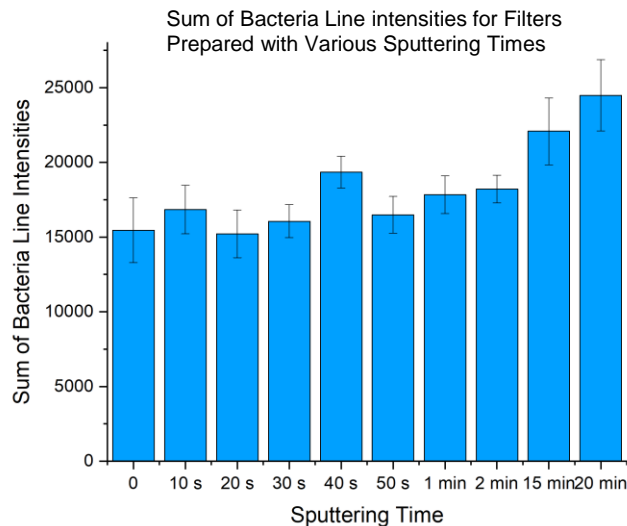


Filter with thin film of silver



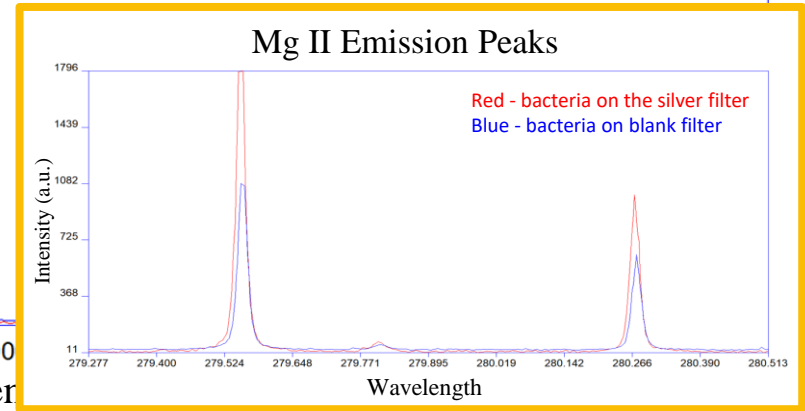
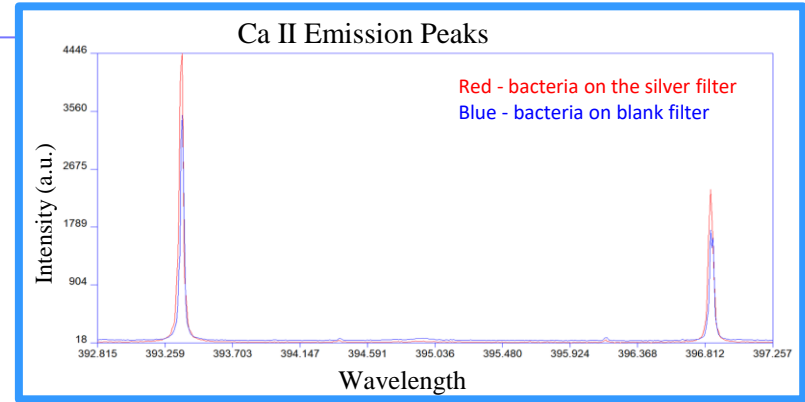
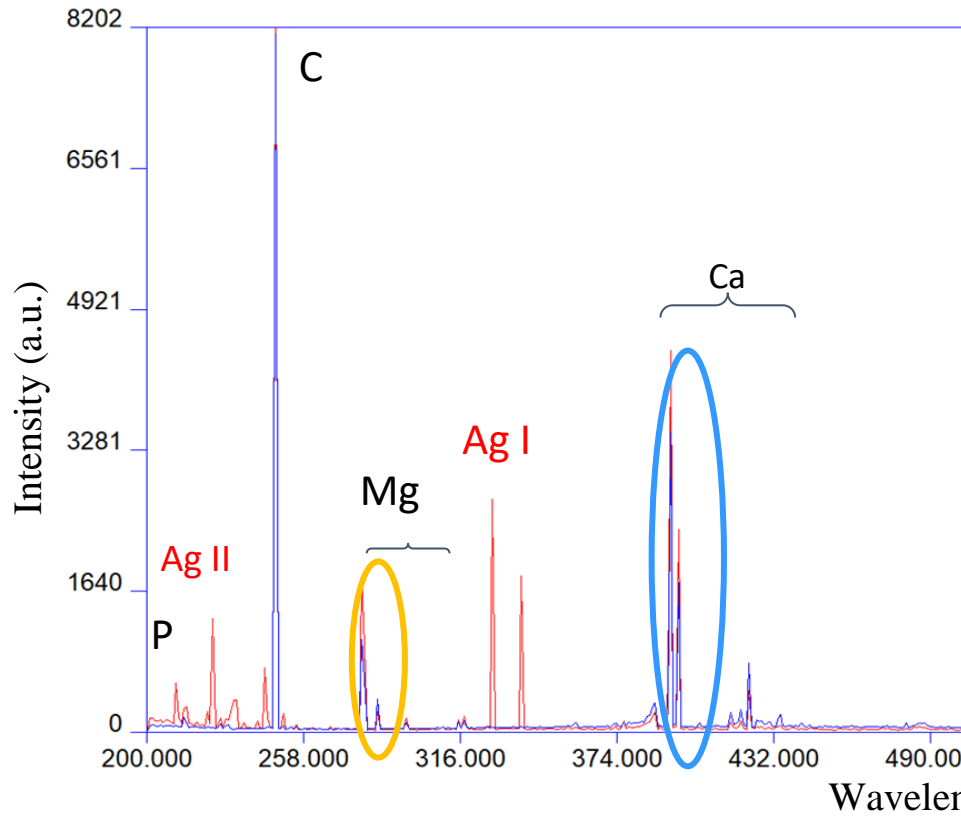
# Results: Enhancement of Bacteria Emission Lines

Filters prepared with various sputtering times were removed from the vacuum chamber, bacteria were deposited, and LIBS was performed on the depositions. 20-30 single-shot LIBS spectra were acquired from each filter.

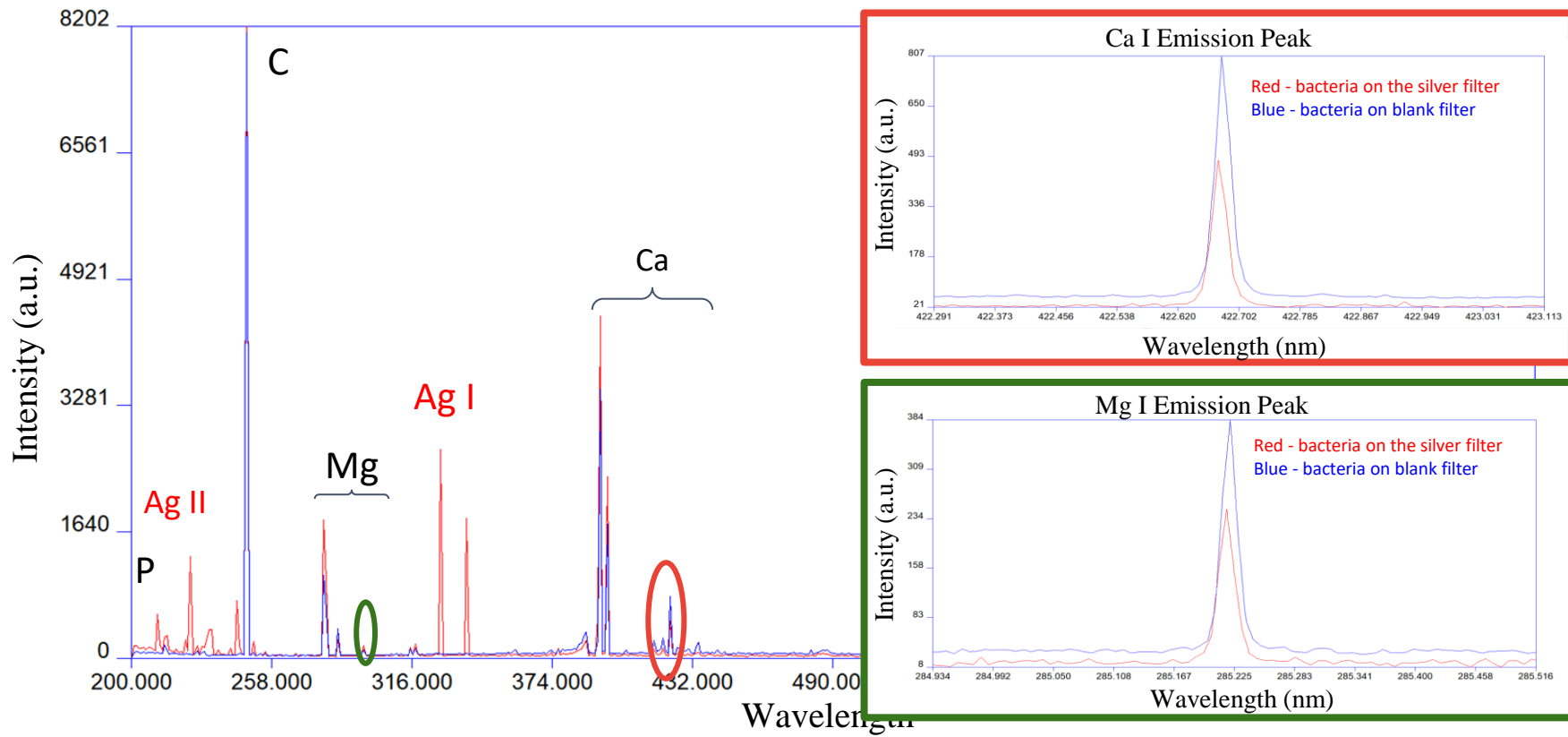


Slight enhancement was observed for deposition times of 15 min or greater.

# Results: Enhancement of Individual Peaks



# Results: Enhancement of Individual Peaks





# Plasma Temperature

The fraction of singly-ionized emission has increased indicating an increase in the temperature of the plasma.

The temperature increase was quantified using Saha-Boltzmann calculations:

$$\frac{I_{\text{ion}}}{I_{\text{atom}}} = 2 \frac{(2\pi m_e kT)^{3/2}}{N_e h^3} \left(\frac{g_A}{\lambda}\right)_{\text{ion}} \left(\frac{\lambda}{g_A}\right)_{\text{atom}} e^{-\frac{(V^+ + E_{\text{ion}} + E_{\text{atom}})}{kT_{\text{ion}}}}$$

Results	Calcium	Magnesium
No Silver Temperature	6010 K	7167 K
With Silver Temperature	6402 K	7602 K
Percent Change	+6.13%	+5.72

Average  
temperature  
increase of  
~ 6%

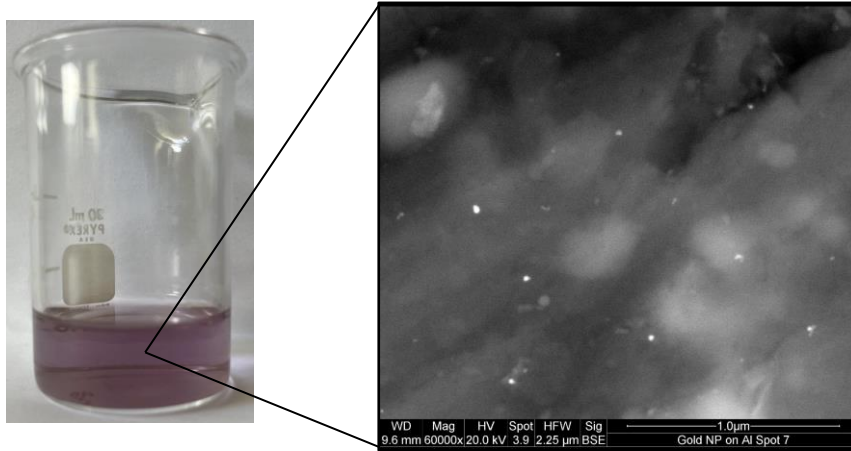
# Conclusions

- A uniform silver film was deposited as shown by SEM and LIBS that is not disrupted by subsequent laser pulses
- Slight bacterial enhancement was observed for deposition times 15 min or greater
- There was an increase in the fraction of singly-ionized emission
- A temperature increase of 6% was observed for deposition times of 15 min and 20 min



# Future Work

- Use nano-particle enhanced LIBS (NELIBS) to increase the emission intensity of our bacteria
- We have successfully produced a nanoparticle suspension using pulsed laser ablation in liquid (PLAL)



Au Nanoparticle suspension

## Next Steps:

Investigate various parameters' (laser pulse energy, volume of liquid, sputtering time) effect on size and spacing of the nanoparticles to observe and optimize enhancement.

# Acknowledgements

- Advisor: Dr. Steven Rehse
- Colleagues:
  - Haiqa Arain
  - Emma Blanchette
  - August Baughan
  - Grace Johnson
  - George Kobrossy
  - Peyton Tillie
- Sponsors:
  - NSERC USRA
  - University of Windsor Outstanding Scholars Program



# Determining Filter Location and Deposition Time

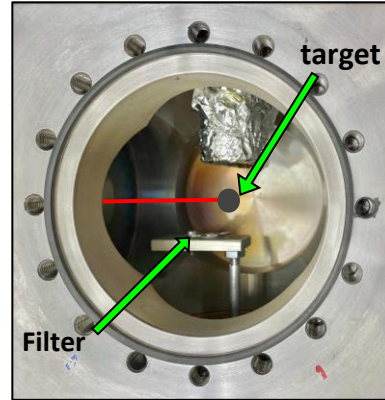
Filter location:



Brass rod



Brass coverage in various locations



Top view of chamber

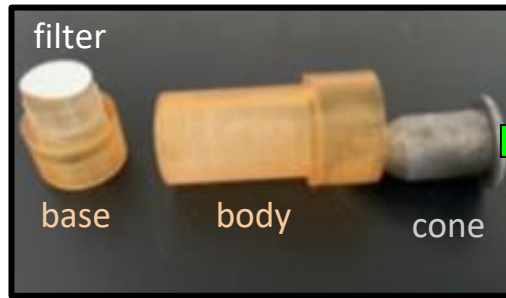


2 min deposition of silver

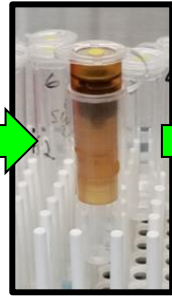
Deposition time:

- 2 min, 4 min, and 8 min sputtering times were investigated
  - ↳ Appeared to be too long, under 1 min would be investigated further with silver

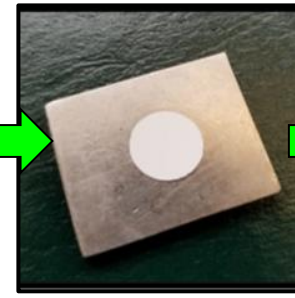
# Bacterial Deposition



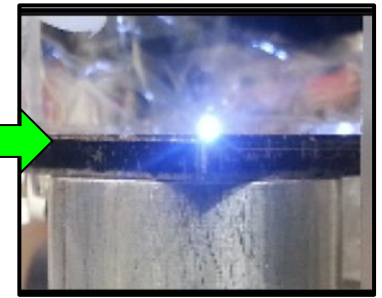
Centrifuge insert piece



Centrifugation



Sample mounted on steel piece



Sample being irradiated by laser pulse

Electron Density from Stark–broadened hydrogen line:

$$N_e = C(N_e, T_e) (\Delta\lambda_{\text{FWHM}})^{3/2}$$